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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

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**APPLICANTS: Li Min; Liao Simon; Sano Masashi; Noguchi Kiyoshi; Ju Kochan; Horng Cheng; H. B. / A. C.					
**CONTINUING DATA VERIFIED: None / A. C.					
** FOREIGN APPLICATIONS VERIFIED: None / A. C.					
PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>			
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO HT01-022	
Verified and Acknowledged Examiners's initials A. C.					
TITLE : FeTa nano-oxide layer as a capping layer for enhancement of giant magnetoresistance in bottom spin valve structures					
U.S. DEPT. OF COMM./PAT. & TM-PTO-438L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for Q.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drawn	Figs. Drawn	Print Fig.
		Primary Examiner		Application Examiner
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